PTO/SB/08A (10-01)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Complete if Known **Application Number** 10/627,931 Filing Date July 25, 2003 David E. SLUTZ First Named Inventor 1775 Group Art Unit Tumer, Archene A. Examiner Name

(use as many sheets as necessary) M8540/279473 Sheet of 2 Attorney Docket Number

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Examine r Initials *	Cite No.1	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Petentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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			First Named Inventor	David E. SLUTZ	
			Group Art Unit	1775	
			Examiner Name		
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Examiner Initials * Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume number(s), publisher, city and/or country where published.			page(s), volume-issue	T²		
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